


PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Makoto IIDA

Attn: OIPE

Application No.: 10/565,760

Group Art Unit: 1722

Filed: January 24, 2006

Docket No.: 126790

For: A METHOD FOR PRODUCING A SINGLE CRYSTAL AND AN APPARATUS
FOR PRODUCING A SINGLE CRYSTAL**REQUEST FOR CORRECTION OF PALM RECORDS**Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,


William P. Berridge
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Registration No. 56,046

WPB:RBI/crh

Date: November 3, 2006

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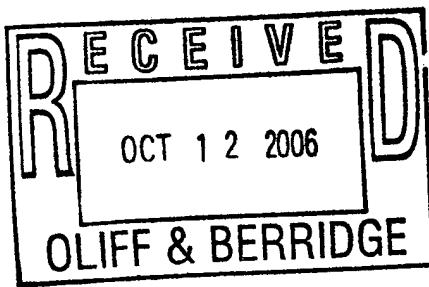
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| APPL NO. | FILING OR 371 (c) DATE | ART UNIT | FIL FEE REC'D | ATTY.DOCKET NO | DRAWINGS | TOT CLMS | IND CLMS |
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| 10/565,760 | 01/24/2006 | 1722 | 900 | 126790 | 5 | 18 | 2 |

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CONFIRMATION NO. 3002

FILING RECEIPT



OC000000020662485

Date Mailed: 10/04/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Assignment For Published Patent Application

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*PLEASE SEE PAGE 2
FOR CORRECTION *

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/07619 06/02/2004

Foreign Applications

JAPAN 2003-282181 07/29/2003

If Required, Foreign Filing License Granted: 09/30/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/565,760**

Projected Publication Date: 01/11/2007

Non-Publication Request: No

Early Publication Request: No

Title

~~Process for producing single crystal and apparatus for single crystal production—~~

Preliminary Class
117 **A METHOD FOR PRODUCING A SINGLE CRYSTAL AND
AN APPARATUS FOR PRODUCING A SINGLE CRYSTAL**

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Title 37, Code of Federal Regulations, 5.11 & 5.15

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